

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Nathan R. Brown

Serial No.: 10/715,264

Filed: November 17, 2003

For: METHODS FOR DETERMINING AMOUNTS AND LOCATIONS OF DIFFERENTIAL PRESSURE TO BE APPLIED TO SEMICONDUCTOR SUBSTRATES DURING POLISHING OF SEMICONDUCTOR DEVICE STRUCTURES CARRIED THEREBY AND FOR SUBSEQUENTL

Confirmation No.: 5086

Examiner: Unknown

Group Art Unit: 1763

Attorney Docket No.: 2269-4375.3US

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

March 1, 2004

Date

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PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Prior to examination of the above-referenced patent application on the merits, entry of the amendments as set forth herein is respectfully solicited.

Amendments to the Specification appear on page 2 of this paper.

Amendments to the Claims are reflected in the listing which begins on page 3 of this paper.

Remarks begin on page 6 of this paper.